Muons, Inc Simulation of Conventional and Unconventional Photocathode Geometries

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Outline

Brief review of numerical toolkit for micro channel plate simulation;

- * Optimization of the photo electron capturing for Funnel MCP;
- Conventional MCPs with composite secondary emitters;
- Comparison of emission properties for different analytic models;
- ✷ Future problems;
- 🗮 Resume.

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Original software toolkit to simulate the MCPs



Part 1.

Funnel MCP

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Funnel type MCP (FMCP)



FMCP is an alternative version of conventional MCP which can prevent the ion feedback damage. FMCP also makes easier the first-strike problem.

Optimization of capturing ratio for photo-electrons by varying the outer radius and resistance of photo cathode

The code POISSON-2

Photo cathode

Pore

U=-2.17kV

U=-2.2kV

Transparent film

U=-2.205

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Efficiency of photo emission



The efficiency of photo-electron capturing depends on many factors (funnel geometry, photo-cathode resistance, voltage etc.). It is strongly depends on the position at the cathode surface

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Electron multiplication in the funnel MCP



The result of numerical simulation for the electron multiplication in 5um pores.
 Parameters: L/D=40; Material properties: Sigma max=3; Umax=400V.
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Numerical results for FMCP simulation





Angular distribution of photo emission is described by Cos(Theta) dependence

Current distribution of secondary electrons at cross-section Z=20um

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Part 2.

Conventional MCP

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Secondary emission for composite materials



These approximations were used in simulation of the INCOM MCP with parameters: D=40um, L/D=40, L=1.6mm, Voltage U=1kV

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Comparison for different Secondary-emission models

1. Guest's Model

$$\sigma(\theta, V) = \left(\frac{V}{V_{\max}} \sqrt{\cos(\theta)}\right)^{\beta} \exp\left[\alpha \left(1 - \cos(\theta)\right) + \beta \left(1 - \frac{V}{V_{\max}} \sqrt{\cos(\theta)}\right)\right]$$

o.ss. $V \ll V_{\max}$
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 $\beta = \frac{1}{2} \left[\alpha \lambda \lambda$

 θ – incident angle, *V* – impact energy, V_{max} – impact energy corresponds to a maximum of SEE yield, α – surface absorption factor, β – smooth factor

3. Lie-Dekker Model

$$\sigma_{max}(\theta) = \sigma_{max}(0) \left(1 + \frac{k\theta^2}{\pi}\right), V_{max}(\theta) = V_{max}(0) \left(1 + \frac{k\theta^2}{\pi}\right)$$
$$\sigma = \sigma_{max} g_n(z_m V / V_{max}) / g_n(z_m),$$
$$g_n(z) = \frac{1 - \exp(-z^{n+1})}{z^n},$$

k=0 for textured carbon, 1.5 for polished surface, 2 for crystalline (1 – default); Z_m - is an argument value corresponds to the maximum of $g_n(z)$, n – is an adjustable parameter (default value is 0.35 for $V \le V_{max}$, z_m =1.84, $g_n(z_m)$ =0.725, and 1 for $V > 3 V_{max}$);

2. Ito's Model $\sigma(\theta, V) = \frac{4x}{(x+1)^2} exp[\beta(1 - \cos\theta)]$ $x = \frac{V}{V_{max}} \sqrt{\cos\theta},$

4. Agarwal's Model

$$\sigma = \sigma_{max} \frac{\frac{2V/V_{max}}{1 + (V/V_{max})^{1.85(\frac{2Z}{A})}}$$

Z is atomic number and A the atomic weight

5. Rodney-Vaugham's Model

$$\sigma = \sigma_{max}(ve^{1-v})^s, v = \frac{v-v_o}{v_{max}-v_o}$$

s=0.62 for *v*<1, and *s*=0.25 for *v*>1. V_o is biggest value for SEE curve $\sigma(V_o)=1$

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Comparison for different models (cont.)



Courtesy of Z.Insepov

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The results of INCOM MCP simulation



MCP parameters: D=40um, L/D=40, L=1.6mm, Voltage U=1kV.
Time resolution for the MCP Rt=33.1 ps. Actual resolution with PC-MCP and MCP-anode gaps will be bigger. Different emission models give difference in the gain computation about 30-40%.

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Nearest future plans

* Extend the field representation in the pores to take into account the tilted electric field in chevron-pair plates which can substantially increase the gain; ***** Incorporate the saturation model to our numerical codes; * Provide systematic comparison for emission models with experimental data.

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Resume

- * Numerical optimization of funnel MCP parameters substantially increased the capturing of photo-electrons and total gain factor;
- Simulation of conventional MCP with secondary emitter of composite material detects a big difference in the gain factor for different analytical models;
- Existing numerical codes should be improved to satisfy the main requirements in simulation of modern MCP photo-detectors.

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